



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79007

Koichi KAWAMURA, et al.

Appln. No.: 10/735,769

Confirmation No.: 3973

Group Art Unit: 1756

Filed: December 16, 2003

Examiner: Daborah Chacko Davis

For: PATTERN FORMING METHOD AND SUBSTANCE ADHERENCE PATTERN MATERIAL

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

An RCE and the required fee and a petition and the required fee for a one month extension of time are being submitted concurrently herewith.

In response to the Office Action dated March 27, 2006, please amend the above-identified application as follows on the accompanying pages.

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